

Notice of References Cited	Application/Control No. 10/727,760	Applicant(s)/Patent Under Reexamination MALI ET AL.	
	Examiner Thinh T. Nguyen	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,621,125	09-2003	Wang, Jeffrey	257/355
	C	US-5,843,816	12-1998	Liaw et al.	438/238
	D	US-6,573,166	06-2003	Chen, Chin-Yang	438/519
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	L	US-			
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NON-PATENT DOCUMENTS

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	U	Stanley Wolf, Silicon Processing for the VLSI area Volume 3, Lattice Press (1995) page 137
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.